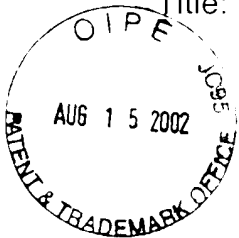


IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/905,320
 Filing Date July 13, 2001
 Inventorship Cem Basceri et al.
 Assignee Micron Technology, Inc.
 Group Art Unit 1762
 Examiner Eric B. Fuller
 Attorney's Docket No. MI22-1657
 Title: Chemical Vapor Deposition Methods of Forming Barium Strontium Titanate
 Comprising Dielectric Layers, Including Such Layers Having a Varied
 Concentration of Barium and Strontium Within the Layer



RESPONSE TO MAY 20, 2002 FINAL OFFICE ACTION
PRELIMINARY AMENDMENT TO ACCOMPANY RCE FILING

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To: Box RCE
 Assistant Commissioner for Patents
 Washington, D.C. 20231

VIA U.S. EXPRESS MAIL

From: Mark S. Matkin (Tel. 509-624-4276; Fax 509-838-3424)
 Wells, St. John, Roberts, Gregory & Matkin P.S.
 601 West First Avenue, Suite 1300
 Spokane, WA 99201-3828

Please enter the following amendments prior to examining the above-identified application.

AMENDMENTS

In the Claims

Please replace the claims with the following clean version of the entire set of pending claims. Cancel all previous versions of any pending claim. As there are no amendments to the claims, and one addition to same, no marked-up version of the claims is provided herewith in any accompanying pages separate from this amendment.